

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10598943	
	Filing Date		2006-09-15	
	First Named Inventor	Peng-Fei Fu		
	Art Unit	1762 1794		
	Examiner Name	Unknown D. S. Nakarani		
Attorney Docket Number		071038.00102		

U.S. PATENTS						Remove
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1					

If you wish to add additional U.S. Patent citation information please click the Add button.

Add

U.S. PATENT APPLICATION PUBLICATIONS						Remove
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
/DSN/	1	20020137870	A1	2002-09-26	Crivello	

If you wish to add additional U.S. Published Application citation information please click the Add button.

Add

FOREIGN PATENT DOCUMENTS							Remove	
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² j	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T ⁵
/DSN/	1	WO99/26112	WO		1999-05-27	DHAL et al.		<input type="checkbox"/>
/DSN/	2	WO9212183	WO		1992-07-23	Crivello		<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button.

Add

NON-PATENT LITERATURE DOCUMENTS							Remove
---------------------------------	--	--	--	--	--	--	--------

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10598943	
Filing Date	2006-09-15	
First Named Inventor	Peng-Fei Fu	
Art Unit	1702	1794
Examiner Name	Unknown D. S. Nakarani	
Attorney Docket Number	071038.00102	

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
/DSN/	1	CRIVELLO ET AL., "The Synthesis, Characterization, and Photoinitiated Cationic Polymerization of Silicon-Containing Epoxy Resins" Journal of Polymer Science Polymer Chemistry Edition, 1990, Vol 28, pages. 479-503, XP 000141356.	<input type="checkbox"/>
/DSN/	2	CRIVELLO ET AL., "The UV Cure of Epoxy-Silicone Monomers, Polymeric Materials Science and Engineering, 1989, pages. 217-227, XP009035836.	<input type="checkbox"/>
/DSN/	3	LABIANCA ET AL., "High Aspect Ratio Resist For Thick Film Applications", Advances In Resist Technology and Processing XII, Spie, 1995, Vol. 2438, pages 846-852, XP002437324.	<input type="checkbox"/>
/DSN/	4	MATSUI ET AL., "Room-temperature nanoimprint and nanotransfer printing using hydrogen silsequioxane", Journal of Vacuum Science & Technology B: Microelectronics Processing and Phenomena, American Vacuum Society, March 2003, Vol. 21, No. 2, pages 688-692, XP012009626.	<input type="checkbox"/>
/DSN/	5	PFEIFFER ET AL., "Reactive Polymers - a Route to Nanoimprint Lithography at Low Temperatures", Proceedings of Spie, Spie, 2003, Vol 5037, pages 203-210, XP-002297929.	<input type="checkbox"/>
/DSN/	6	PFEIFFER ET AL., "Multistep profiles by mix and match of nanoprnt and UV lithography", Microelectron;c Engineering, 2001, Vol. 57-58, pages 381-387, XP004302289.	<input type="checkbox"/>
/DSN/	7	SUN XIAOYUN ET AL., "Multilayer resist methods for nanoimprint lithography on nonflat surfaces", Journal of Vacuum Science & Technology B: Microelectronics Processing and Phenomena, American Vacuum Society, 1998, Vol. 16, No. 6, pages 3922-3925, XP012007311.	<input type="checkbox"/>
/DSN/	8	International Search Report, International Application No. PCT/US2005/019340, dated June 29, 2007.	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature	/D. S. Nakarani/	Date Considered	06/18/2009
--------------------	------------------	-----------------	------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10598943
Filing Date	2006-09-15
First Named Inventor	Peng-Fei Fu
Art Unit	1782 1794
Examiner Name	Unknown D. S. Nakarani
Attorney Docket Number	071038.00102

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.